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Developing a Virtual Model of a Second Order System to Simulation Real Laboratory Measurement Problems





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The Problem



Most of the student's educational exposure is to well behaved, deterministic problems with known results.

Most courses expose students to

- material in modules in book chapters
- with exercises/problems at end of the chapter
- majority of the material found in chapter/book







The Problem



Laboratory is the perfect place for students to become exposed to real world problems and solutions to those problems.

Laboratory is the perfect place to put student's knowledge of basic STEM material to the test.

However, many times the real world measurement is much more complicated than the textbook.

Students often struggle with methods and procedures to solve a real measurement problem ____ (with no answer at the back of the book)









A simple mass, spring, dashpot system is used to measure displacement and acceleration



Numerical processing of integration/differential needed to process data













Requires extensive use of a wide variety of different analytical tools.

Significant numerical data manipulation needed.

- Regression Analysis
- Data Cleansing
- Integration
- Differentiation













The data acquisition system and transducers are intentionally selected such that the majority of possible errors exist in the data









The students are forced to integrate key STEM material and concepts to solve this problem

- Numerical processing
- Filtering
- Thinking is required !!!











The real test configuration has many problems that all simultaneously plague the measurement.

Many times students are frustrated with the significant open-ended aspects of this exercise.

This is due to the large number of items that simultaneously plague the measurement.

Multisemester Interwoven Dynamic Systems Project









In order to assist the student in understanding all of the individual effects, a virtual measurement system was developed.

This enables the student to add individual effects and see the result on the measurement made.

The pieces of the Virtual Measurement System are described in the following sections.









The entire Simulink model











The SDOF system portion











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The accelerometer measurement portion



The LVDT & RC filter measurement portion









The entire GUI Interface

🥑 basic_system	
System characteristics Mass (kg), m ● ▶ 100 50 Damping (kg/sec), c 5 ● ▶ 100 13.585 Stiffness (N/m), k 0 ● ▶ 10.000 5000	f(t) x(t) k t c Mass - Spring - Dashpot System
Accelerometer	
Sensitivity (V per m/sec^2), as 0.003	LVDT sensitivity (V/m), Ls 400
Bias (V), ab -2 • 2 0	LVDT bias (V), Lb -10 • 10 0
Slope of drift (V/sec), ad -0.1 • 0.1 0	LVDT sinusoidal noise amplitude (V), Lna 0 • 1 0
Add random noise	LVDT sinusoidal noise frequency (Hz), Lrf 1
Simulate and store results	RC Circuit Low-Pass Filter on LVDT
m c k id sh ih as	ab ad an Ls Lb Lna Lnf RC
Run1 50.0 13.6 5000 0.010 0.00 0.003 Remove For selected run(s), plot: Image: Displacement Imag	0.00 0.00 0.00 400 0.00 0.000 60.0 0.025 ▲
Plot Velocity Acceleration	Heal-world accelerometer output Real-world LVDT output, unlittered Real-world LVDT output, filtered









The system characteristic definition of

mass, damping and stiffness

Syste	em character	istics
Mass (kg), m	0 •	▶ 100 50
Damping (kg/sec), c	-5 •	▶ 100 13.585
Stiffness (N/m), k	0	▶ 10,000 5000

along with IC and forcing function

Initia	l condition and forcing functions
	Initial displacement (m), id 0.01
	Impulse height, ih 🔽 🛛
	Step height, sh 0









The accelerometer parameters can be entered

along with the LVDT

ALL	verei	omet	CI		
Sensitivity (V per r	n/sec	c^2), as	0.003	3	
Bias (∨), ab	-2	•		• 2	0
Slope of drift (V/sec), ad	-0.1	•		▶ 0.1	0
	ĒÆ	Add ran	dom noise	l.	
Peak noise amplitude (V), an	1e-1	00 🔳		▶ 1	0.001
		arcene in a		and the set	

LVD	Г	
LVDT sensitivity (V/n	n), Ls 🛛 400	
LVDT bias (V), Lb	10 •	• 10 0
LVDT sinusoidal noise amplitude (V), Lna	0 •	▶ 1 0
LVDT sinusoidal noise frequency (Hz), Lnf	1 -	▶ 150 60

and RC filter setting

RC Circuit Low-Pass Filter on LVDT





Virtual Measurement System GUI



User enters M, C, K system. User enters the amount of experimental distortion on the accel. (sensitivity, bias, drift) and displacement LVDT (sensitivity, bias, noise) and the low pass filter characteristics to virtually "simulate" the measurement environment.

Data can be exported with ability to select which outputs and what effects are included on the measurement.











The student can quickly study the measurement issues associated with drift, bias and offset.

These effects are significant when numerically processing the data to perform differentiation and integration.

Several cases are shown to illustrate the usefulness of the Virtual Measurement System.









Differentiation of LVDT measurement and noise













Integration of the accelerometer measurement











Summary



Students tend to struggle when trying to process real world measurements.

All of their STEM knowledge must come to bear to solve these types of problems.

A Virtual Measurement System was developed to assist students in breaking down the measurement problem into pieces which all contribute to the distortion of the real measurement.







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Multi-Semester Interwoven Project for Teaching Basic Core STEM Material Critical for Solving Dynamic Systems Problems





